

Low-threshold Fiber-coupled Erbium Microlasers on a Chip

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Outline

● Introduction

- Background and motivation

● Experimental results

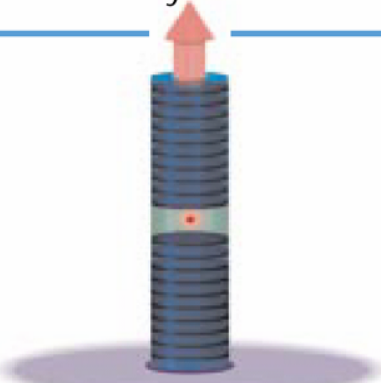
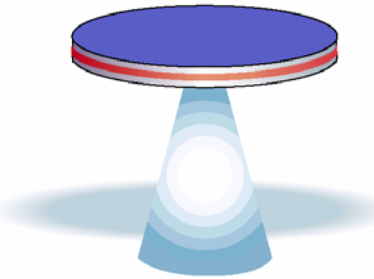
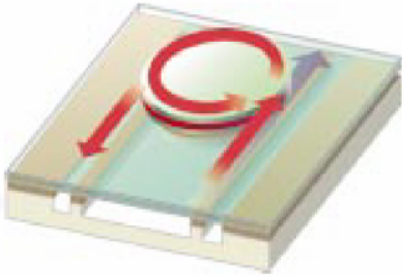
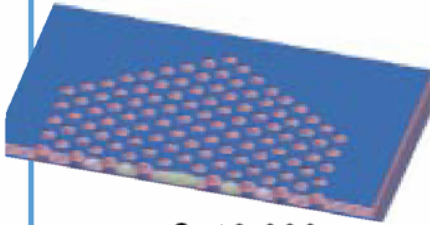
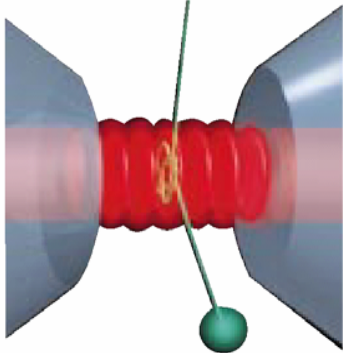
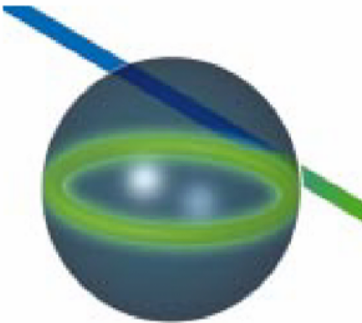

- Process flow for ultra-high-Q planar microcavities
- Sol-gel technology and surface functionalization of a microcavity on a chip
- Laser performance of the microlasers

● Future work

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Introduction to Microcavity

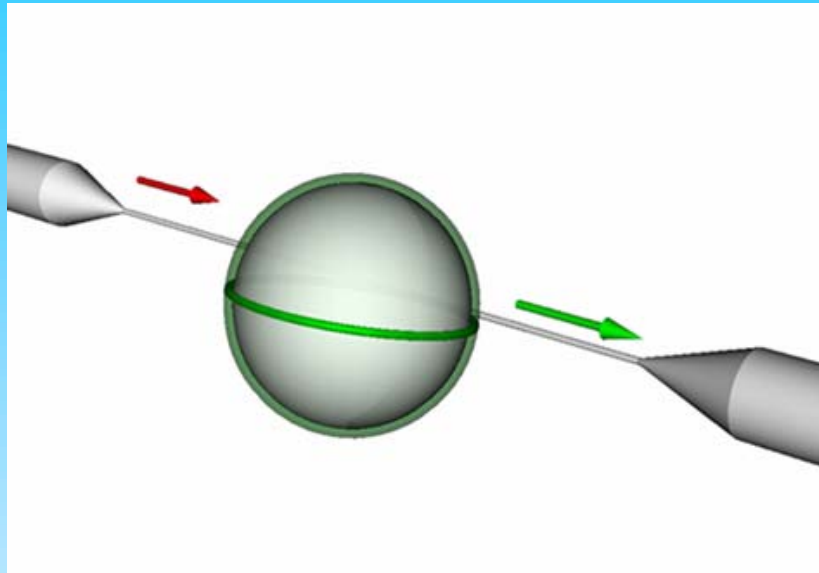
	Fabry-Perot	Whispering gallery		Photonic crystal
High Q	 <p>Q: 2,000 V: $5 (\lambda/n)^3$</p>	 <p>Q: 12,000 V: $6 (\lambda/n)^3$</p>	 <p>Q_{III-V}: 7,000 Q_{Poly}: 1.3×10^5</p>	 <p>Q: 13,000 V: $1.2 (\lambda/n)^3$</p>
Ultrahigh Q	 <p>F: 4.8×10^5 V: $1,690 \mu\text{m}^3$</p>	 <p>Q: 8×10^9 V: $3,000 \mu\text{m}^3$</p>	 <p>Q: 10^8</p>	

“Optical microcavities“, *Kerry Vahala*, Nature, Vol. 424, pp. 839, 2003

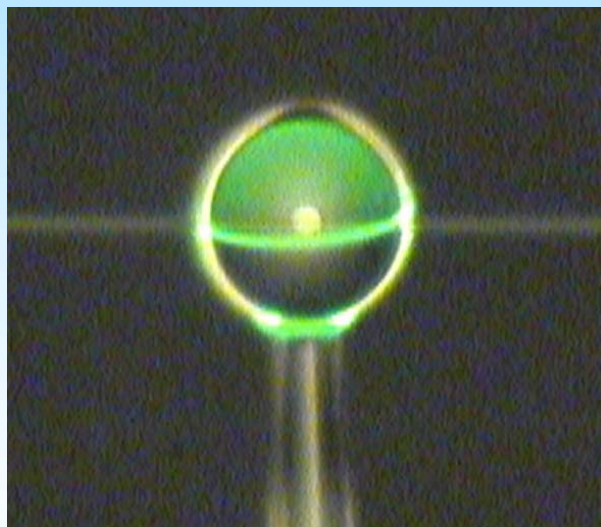
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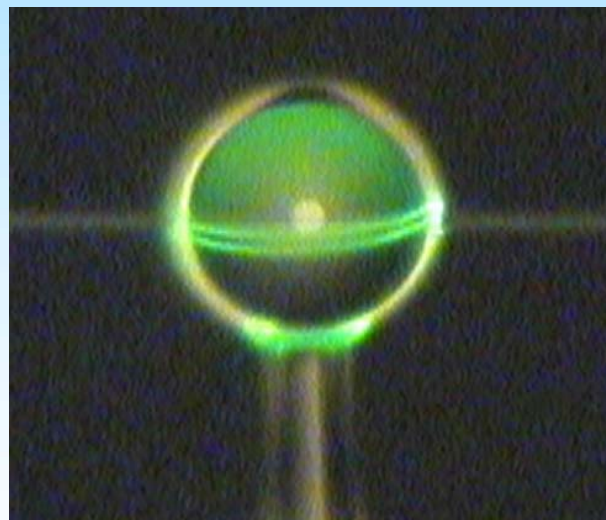
Previous work



- **Surface functionalization:** Er-doped sol gel thin film coated microsphere
- Both doping concentration and thickness could be adjusted, so that both cw and pulsed operation are possible



$m=1$



$m=1-1$

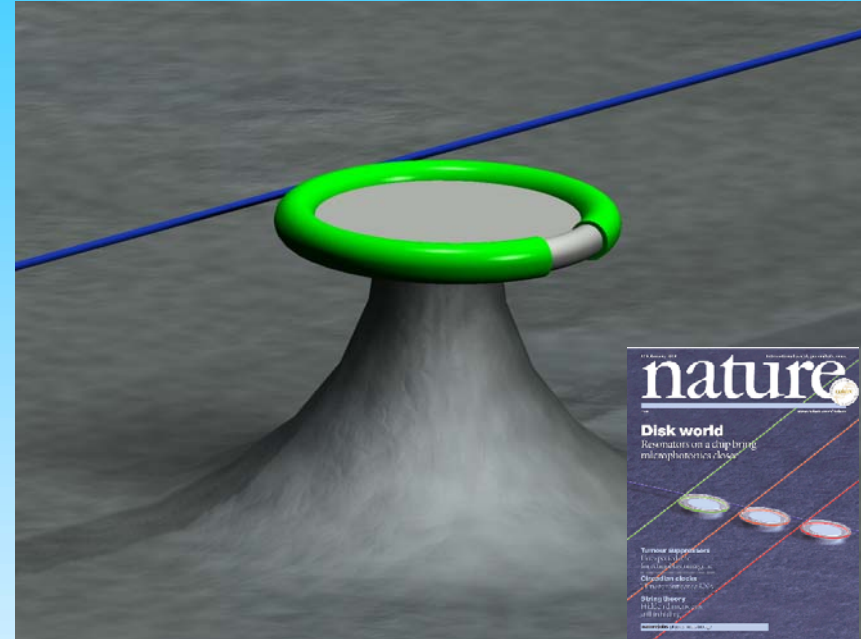
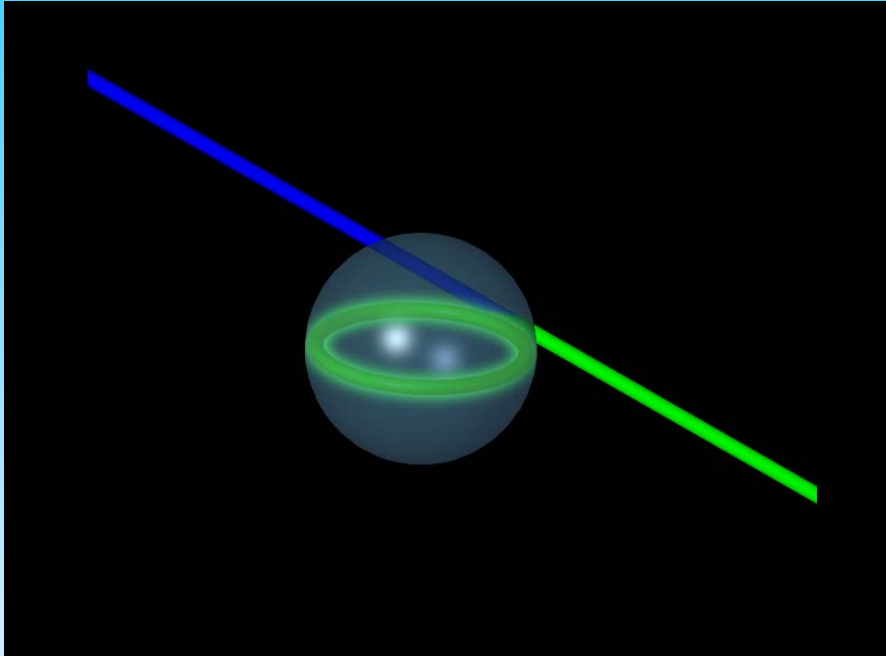


$m=1-4$

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Motivation



The resonator modes are strongly confined just within the inside surface by continuous total internal reflection.

- Chip-based microcavities are integrable with other optical or electronic components
- Simplified mode spectrum compared with microsphere cavities

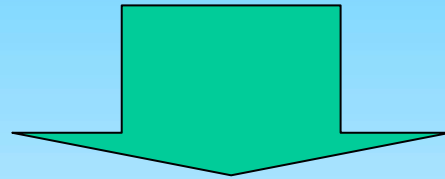
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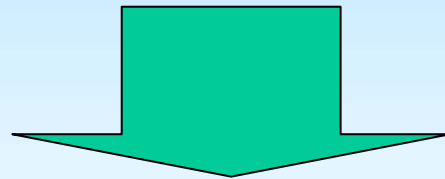
Surface Functionalization of Microtoroid

Fabrication of microtoroids

Preparation of sol gel



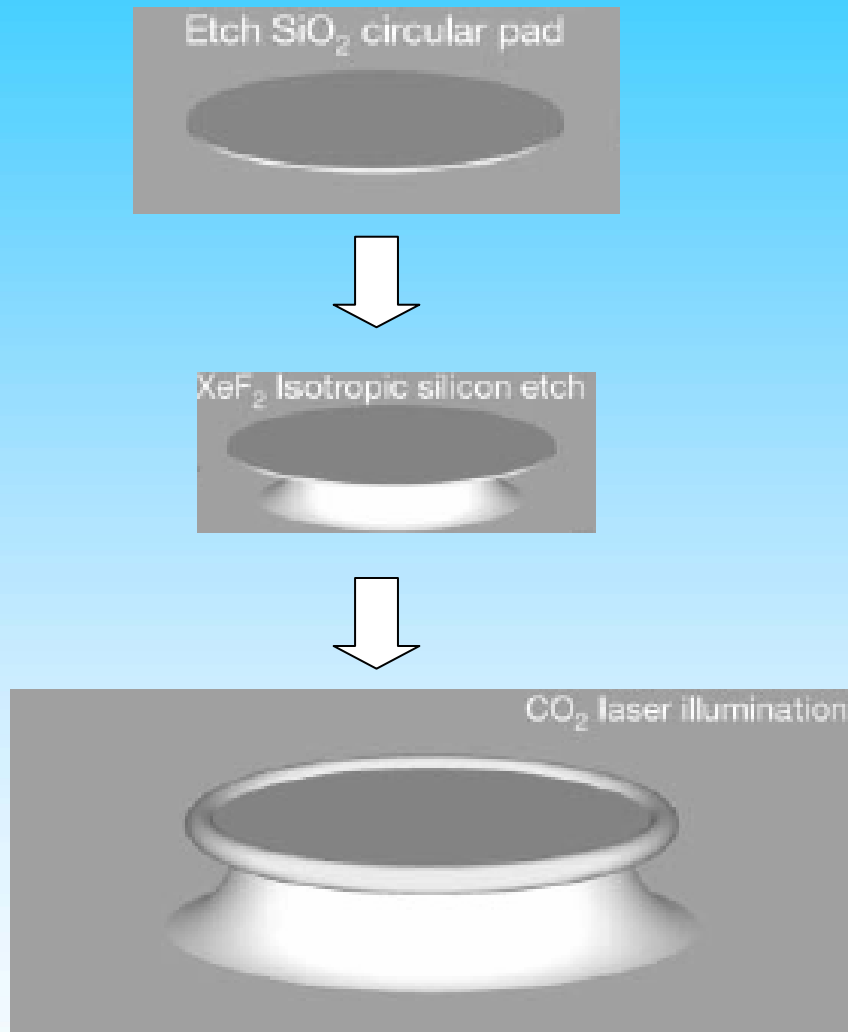
Surface functionalized microtoroids



Microlasers on a chip



Process Flow for Ultra-high-Q Microcavity



Steps:

1. Use XeF₂ etch to remove Si, (SiO₂ disks act as etch mask during the XeF₂ etching process)
2. Selectively heat and reflow the undercut SiO₂ disks using a CO₂ laser (10.6 microns) (SiO₂ has a strong optical absorption at 10.6 microns)

Ultra-high-Q planar microcavity

Silica Reflow Process

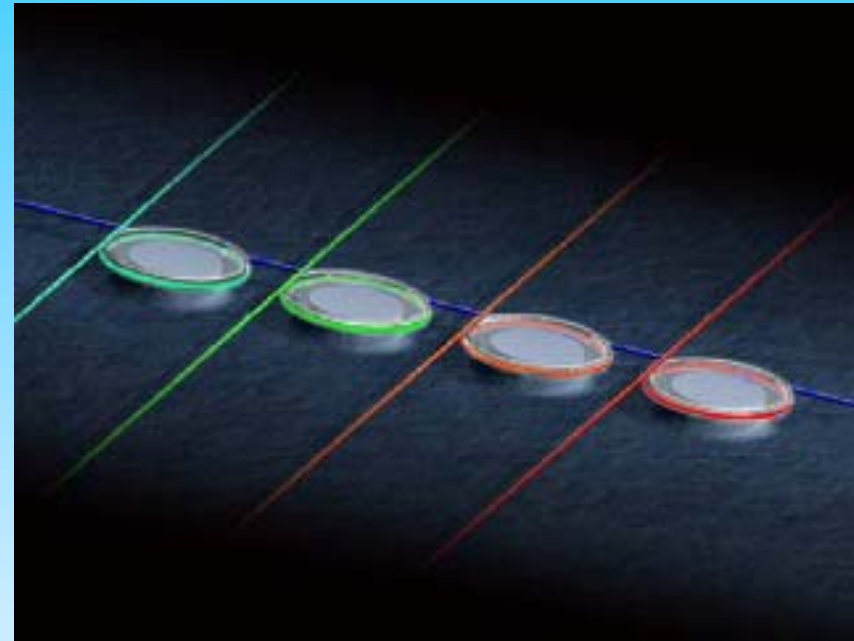
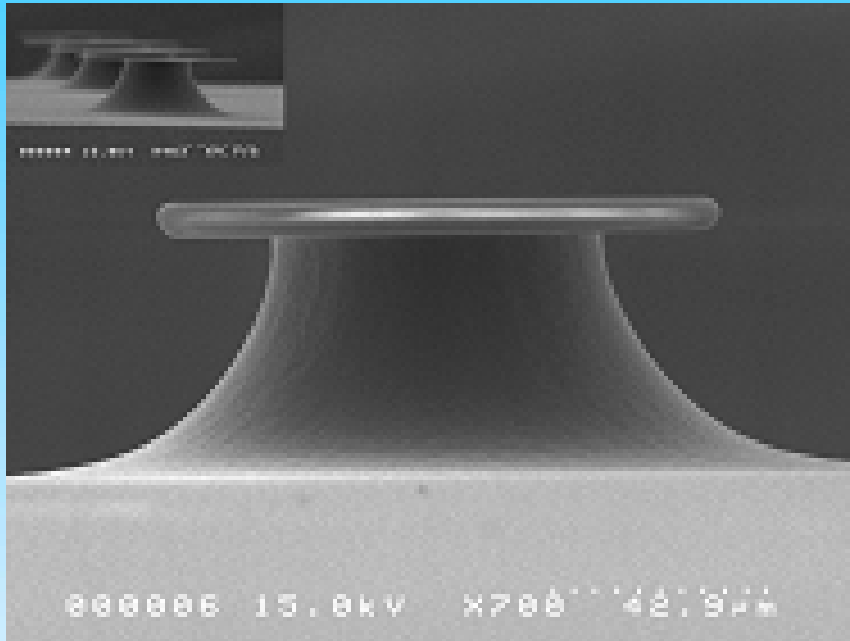


- SiO_2 has a strong optical absorption for CO_2 laser
- Si pillar under the silica disk works as a thermal sink
- Typical laser intensity $\sim 100 \text{ MW/m}^2$

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Ultra-High-Q Microcavity on a Chip



Advantages:

- Fabricated in parallel using wafer-scale processing methods

“Ultra-high-Q toroid microcavity on a chip”, *Deniz Armani, Tobias Kippenberg, Sean Spillane and Kerry Vahala*, Nature, Vol. 421, 925-929, 2003

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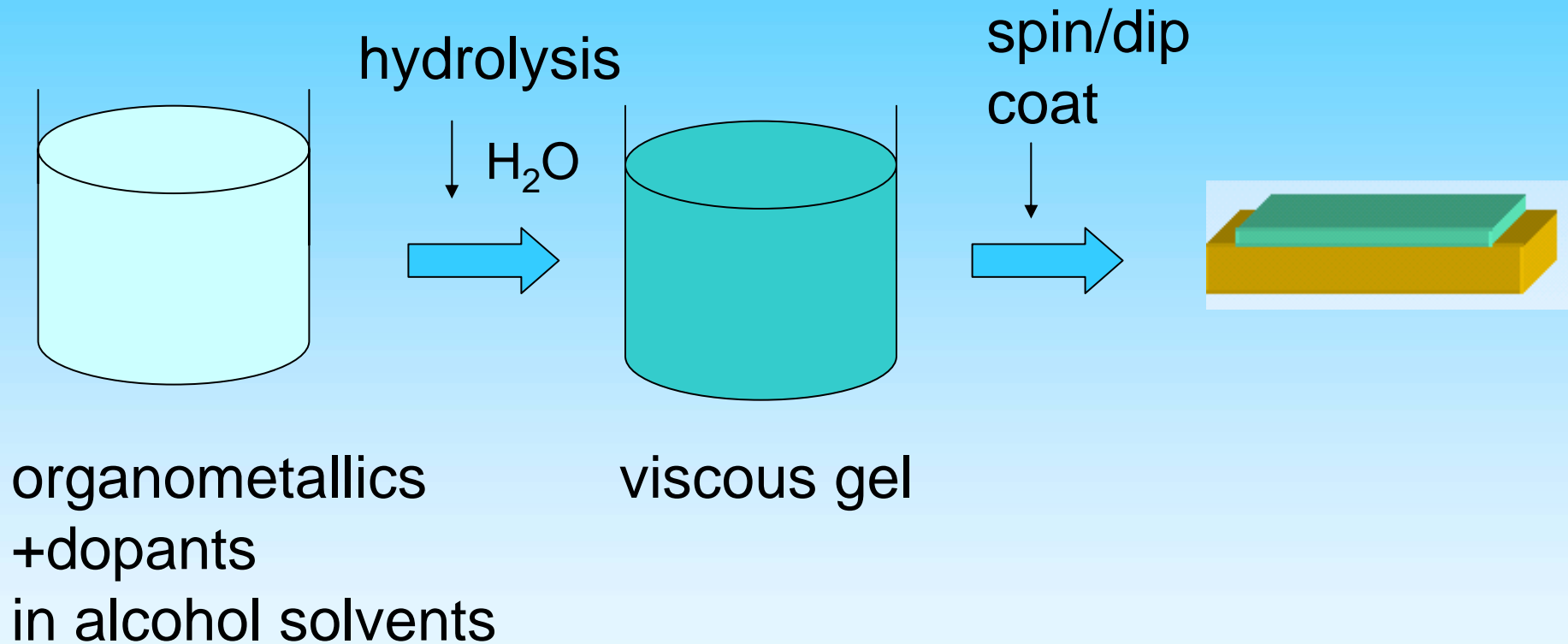


Advantages of Sol-gel Method

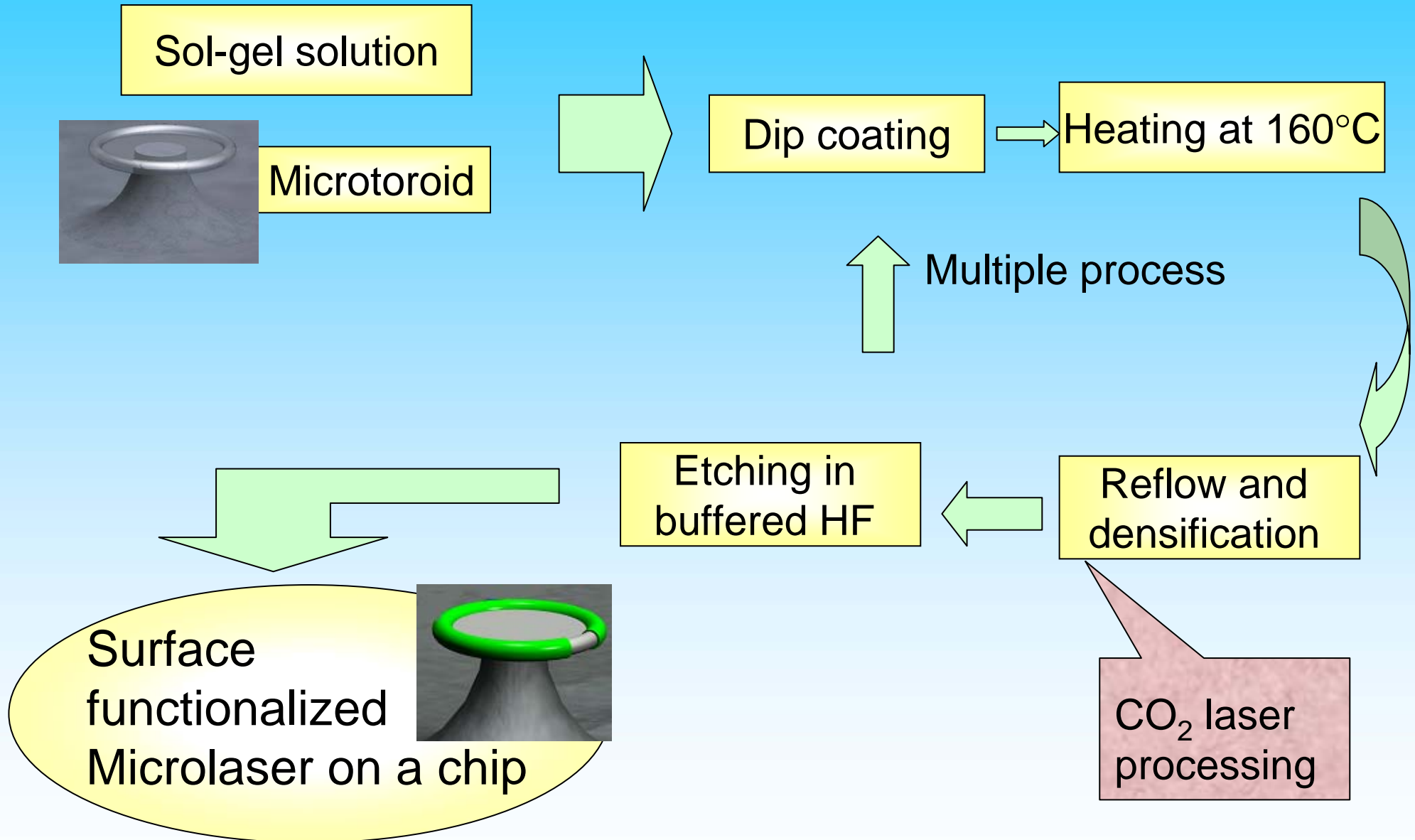
- Involves liquid chemical synthesis of homogeneous materials
- Versatile method to deposit thin films on non-planar surfaces
- Low cost and simple procedure
- Environmentally safe, versus other processes such as chemical vapor deposition (CVD)



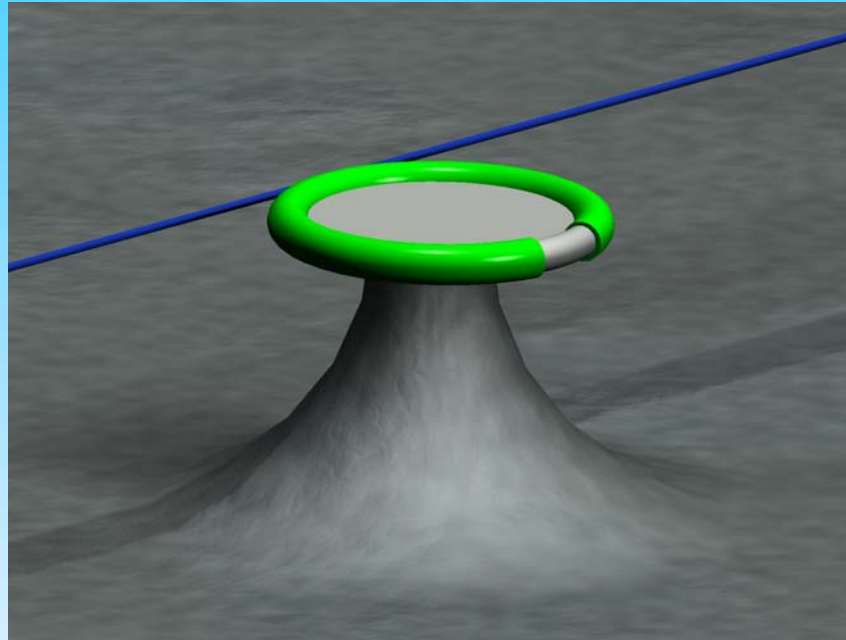
Sol Gel Process



Process Flow



Microlaser on a Chip



● Surface functionalized microtoroid cavity →
Microlaser on a chip

“Fiber-coupled erbium microlasers on a chip”, *Lan Yang, Deniz Armani, and Kerry Vahala*, *Appl. Phy. Lett.*, Vol. 83, 825-826, 2003

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Achieve Low Threshold

Limiting Factors

Materials loss

Surface scattering

Large mode volume

Low coupling efficiency

Our solutions

Low loss medium

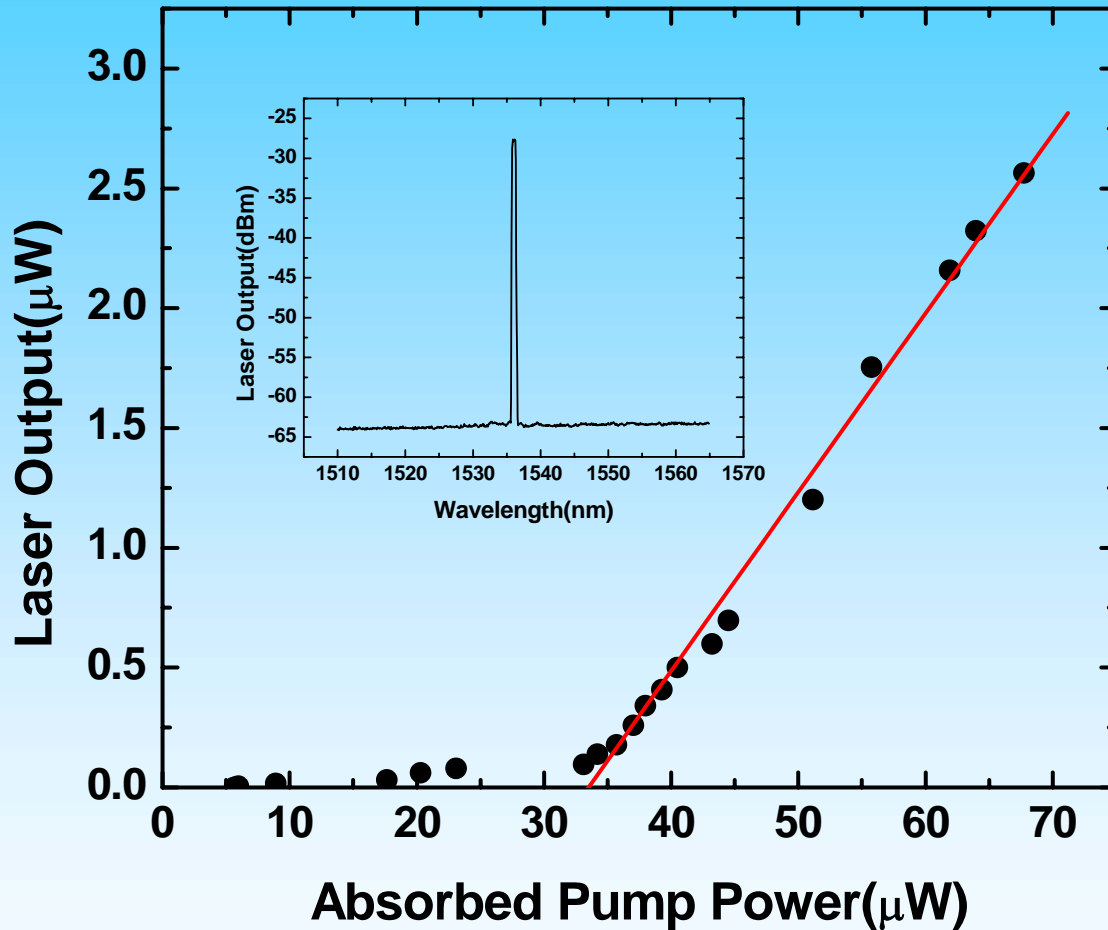
CO₂ reflow process

Highly confined mode

Efficient fiber taper coupling scheme



Laser Performance



- Toroid diameter is 80- μm
- Pump wave is in the 980-nm wavelength band
- Differential quantum efficiency:

$$\eta = \frac{P_{laser}}{P_{pump} - P_{th}} \frac{\lambda_{laser}}{\lambda_{pump}} \sim 11\%$$

Future Work

- **Investigate on factors that affect the coupling efficiency between microtoroid and taper:**
 - **Air gap between resonators and coupling taper**
 - **Phase matching and field overlap between taper and resonators modes**

- **Study variations on surface functionalization:**
 - **Doping concentration**
 - **Different doping ions: Er-Yb codoped, Nd, etc**

- **Integration with other electronic and optical components**



Summary

- **Surface functionalization of ultra-high-Q microcavity on a chip**
- **First chip-based erbium microlasers demonstrated**
 - ❖ **single mode**
 - ❖ **ultra-low threshold**
- **Future work: further characterization of the laser performance**

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***Presentation will be available at
<http://www.its.caltech.edu/~vahalagr>***

Thanks for your attention!

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